



**MS AF**  
REPLY UNDER  
37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2857

PATENT  
4450-0123P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Iqbal M. DAR et al. Conf.: 8401  
Appl. No.: 09/975,722 Group: 2857  
Filed: October 11, 2001 Examiner: BARBEE, Manuel  
For: AUTOMATED MONITORING SYSTEM, VIRTUAL  
OVEN AND METHOD FOR STRESS TESTING  
LOGICALLY GROUPED MODULES

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

**MS AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 23, 2004

Sir:

In reply to the Office Action dated October 27, 2003, the due date for response having been petitioned to be extended two (2) months to March 25, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Claim Set As Amended; and

Remarks.

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